

Notice of References Cited	Application/Control No. 10/552,529		Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner ADAM A. ARCIERO		Art Unit 1795	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,609,975 A	03-1997	Hasegawa et al.	429/217
	B	US-			
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	D	US-			
	E	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N	JP 2002-100357 A	04-2002	Japan	MANABU et al.	
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NON-PATENT DOCUMENTS

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	U	IPDL PAJ JPO Machine Translation for JP 2002-100357 A (04-2002)
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